

GAU 2813
#2 Filed
T. J. J. J.
3-17-99

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Robert Havemann

Serial No.: 09/216,214

Filing Date: 12/18/98

Title: Enhancements to Polysilicon Gate

Docket No.: TI-21570

Examiner: C. Bowers Jr.

Art Unit: 2813

ELECTION

RECEIVED
MAR 10 1999
GROUP 2100

Assistant Commissioner for Patents
Washington, D.C. 20231

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(A)
I hereby certify that the above correspondence is being deposited with
the U.S. Postal Service as First Class Mail in an envelope addressed to
Assistant Commissioner for Patents, Washington, D.C. 20231.

Dear Sir:

Tina Rendon
Tina Rendon

3-4-99
Date

The following Election is offered in response to the Examiner's Office Action dated 2/5/99. It is respectfully submitted as a full and complete response to the Action.

In response to the Examiner's restriction requirement, Applicant elects prosecute Claims 1-2 and 8-9 of Group I without traverse.

If the Examiner has any questions or other correspondence regarding the application, Applicant requests that the Examiner contact Applicant's attorney at the below listed telephone number and address.

Texas Instruments Incorporated
P.O. Box 655474 M/S 3999
Dallas, TX 75265
(972) 278-9694 or (972) 917-5651
Fax: (972) 917-4418

Respectfully submitted,

Jacqueline J. Garner
Jacqueline J. Garner
Reg. No. 36,144